Roman Khakimov

List of Publications by Year in descending order

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1307594 1720034 7 246 7 7 citations g-index h-index papers 7 7 7 300 docs citations times ranked citing authors all docs

#	Article	IF	CITATIONS
1	Influence of the Annealing Temperature and Applied Electric Field on the Reliability of TiN/Hf _{0.5} Zr _{0.5} O ₂ /TiN Capacitors. ACS Applied Electronic Materials, 2021, 3, 4317-4327.	4.3	12
2	Impact of the Atomic Layer-Deposited Ru Electrode Surface Morphology on Resistive Switching Properties of TaO _{<i>x</i>} -Based Memory Structures. ACS Applied Materials & Samp; Interfaces, 2020, 12, 55331-55341.	8.0	14
3	Influence of ALD Ru bottom electrode on ferroelectric properties of Hf0.5Zr0.5O2-based capacitors. Applied Physics Letters, 2020, 117, .	3.3	15
4	Synthesis of Large Area Two-Dimensional MoS ₂ Films by Sulfurization of Atomic Layer Deposited MoO ₃ Thin Film for Nanoelectronic Applications. ACS Applied Nano Materials, 2019, 2, 7521-7531.	5.0	34
5	Temperature controlled Ru and RuO2 growth via O* radical-enhanced atomic layer deposition with Ru(EtCp)2. Journal of Chemical Physics, 2019, 151, 204701.	3.0	18
6	Mitigating wakeup effect and improving endurance of ferroelectric HfO2-ZrO2 thin films by careful La-doping. Journal of Applied Physics, 2019, 125, .	2.5	110
7	La-doped Hf0.5Zr0.5O2 thin films for high-efficiency electrostatic supercapacitors. Applied Physics Letters, 2018, 113, .	3.3	43